

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

PATENT APPLICATION

Inventor: Jong-Jan Lee, et al.

March 21, 2005

Serial No.: 10/625,065

Docket No. SLA0696

Filed: July 22, 2003

Group No. 1765

Confirmation No. 8265

Entitled: FABRICATION OF SILICON-ON-NOTHING (SON) MOSFET
FABRICATION USING SELECTIVE ETCHING OF Si1-X GEX
LAYER

STATUS INQUIRY

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Sir:

It has been over 18 months since the filing of this application and applicant has not yet received an Office Action or other response on the merits of this application. Accordingly, applicants' attorney-of-record, whose name and address appear below, hereby inquires as to the status of the above-identified application. Please inform the attorney-of-record of the status of this application by facsimile or letter at the contact information below. Thank you for your attention to this matter.

Respectfully submitted,

Date:

03/21/05

By:

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